



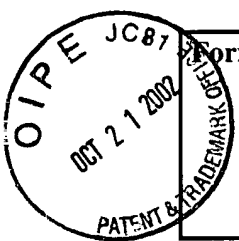
This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-1351 (Order No. XACTP010).

Respectfully submitted,  
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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<table style="width: 100%;"> <tr> <td style="width: 50%;">           Atty. Docket No.            XACTP010            Applicant:            Tal Givoly et al.            Filing Date:            10-23-01         </td> <td style="width: 50%;">           Application No.:            10/039,273             Group Art Unit:            2155         </td> </tr> </table>	Atty. Docket No. XACTP010 Applicant: Tal Givoly et al. Filing Date: 10-23-01	Application No.: 10/039,273  Group Art Unit: 2155
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**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	2002/0099806	07/25/02	Balsamo et al.	709	223	11/30/2000
	B	6,405,251	07/11/02	Bullard et al.	709	224	03/25/1999
	C	2002/0091636	07/11/02	Bullatd et al.	705	40	03/25/1999
	D	2002/0013841	01/31/02	Schweitzer et al.	709	224	08/21/2001
	E						
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	I						
	J						
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**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L							
	M							
	N							
	O							
	P							

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	

Examiner	Date Considered
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.